



FPD Materials & Components Japan TC Chapter and FPD Metrology Japan TC Chapter

Joint Meeting

Japan Standards Spring Meetings 2026

Thursday, March 19, 2026

SEMI Japan Office, Tokyo, Japan / Official Virtual TC Chapter Meeting (Hybrid)

2:00 PM - 5:00 PM JST

AGENDA

1 Welcome/Call to Order

- 1.1 Introduction
- 1.2 Required Elements (Membership Requirements, Antitrust and Intellectual Property Reminders, and Effective Meeting Guidelines)
- 1.3 Agenda Review

2 Review of Previous Meeting Minutes

3 Technical Committee Award

4 Liaison Report

- 4.1 Japan Regional Standards Committee (JRSC)
- 4.2 Global Coordinating Subcommittee (GCS)
 - FPD Materials & Components GCS
 - FPD Metrology GCS
- 4.3 FPD Metrology Korea TC Chapter
- 4.4 FPD Metrology Taiwan TC Chapter

5 Staff Report

6 Ballot Review

<i>Doc #</i>	<i>Task Force</i>	<i>Document Title</i>
7383	FPD Mask TF	Reapproval of SEMI D20-0706 (Reapproved 0221), Terminology for FPD Mask Defect
7384	FPD Mask TF	Reapproval of SEMI D21-0706 (Reapproved 0221), Terminology for FPD Mask Pattern Accuracy
7412	FPD Mask TF	Reapproval of SEMI D42-0421, Specification for Ultra Large Size Mask Substrate Case
7403	FPD Mask TF	Revision to SEMI D53-0421, Specification for Flat Panel Display (FPD) Pellicles
7404	FPD Materials & Components Maintenance TF	Line Item Revision to SEMI D9-0303 (Reapproved 0321), Terminology for Flat Panel Display (FPD) Substrates
7413	Flexible Display TF	Revision to SEMI D80-0421, with title change from Test Method for Measurement of Water Vapor Transmission Rate for High Gas Barrier Plastic Film in a Short Time to Test Method for Measurement of Water Vapor Transmission Rate for High Gas Barrier Plastic Films Using a Quadrupole Mass Spectrometer

7 Subcommittee & Task Force Reports

- 7.1 Flexible Display Task Force
- 7.2 FPD Mask Task Force
- 7.3 FPD Materials & Components Maintenance Task Force

8 Old Business

- 8.1 Project Period Review
- 8.2 5-Year Review
 - SEMI D74-1121, Guide for Measuring Dimensions of Plastic Films/Substrates

9 New Business

- 9.1 Leadership Change

10 Action Item Review

- 10.1 Open Action Items

<i>Item #</i>	<i>Assigned to</i>	<i>Details</i>
FPDM&C_202510_15_01	Flexible Display Task Force	To prepare SNARF for Revision to D80, and to submit ballot for GCS Approval for Cycle 1.
FPDM&C_202510_15_02	SEMI Staff	To send SNARF for Revision to D80 to Global TC members for 2 weeks review.
FPDM&C_202510_15_03	Flexible Display Task Force and SEMI Staff	To submit D80 Revision ballot for Cycle 1.



FPDM&C_202510_15_04	FPD Mask TF	To prepare SNARF for Revision to D42, and to submit ballot for GCS Approval for Cycle 1.
FPDM&C_202510_15_05	FPD Mask TF and SEMI Staff	To submit SEMI D20 Reapproval ballot (Doc.#7383), SEMI D21 Reapproval ballot (Doc.#7384), SEMI D53 Revision ballot (Doc.#7403), SEMI D42 Revision ballot for Cycle1.
FPDM&C_202510_15_06	FPD Materials & Components Maintenance TF and SEMI Staff	To submit Line Item Revision to D9-0303 (Doc.#7404) for ballot Cycle 1.

10.2 New Action Items

<i>Item #</i>	<i>Assigned to</i>	<i>Details</i>

<FPD Metrology Japan TC Chapter Part>

11 Ballot Review

None

12 Subcommittee & Task Force Reports

12.1 FPD Metrology Maintenance Task Force

13 Old Business

13.1 Project Period Review

13.2 5-year Review

14 New Business

15 Action Item Review

15.1 Open Action Items

<i>Item #</i>	<i>Assigned to</i>	<i>Details</i>
None		

15.2 New Action Items

<i>Item #</i>	<i>Assigned to</i>	<i>Details</i>



16 Next Meeting and Adjournment

16.1 The next meeting is scheduled for <date> at <event/location>.